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PCN #: 129
Notification Date:
5 October 2011

Product / Process Change Notice

Parts Affected:

Chip process CP195, NPN small signal transistors, wafers, and die in chip form.

Extent of Change:

The CP195 wafer process has been discontinued and replaced with the CP318V wafer process. The CP195 chip process measures 30 x 30 mils and the CP318V chip process measures 26 x 26 mils. See Figures 1 and 2 for die geometry.

Reason for Change:

An alternate wafer foundry was approved for NPN small signal transistor processes.

Effect of Change:

This change does not affect the electrical characteristics of any device.

Qualification:

Standard evaluation and qualifications completed resulting in no electrical rejects.

Effective Date of Change:

Existing inventory will be shipped until depleted.

Sample Availability:

Please contact Salesperson or Manufacturer's Representative.

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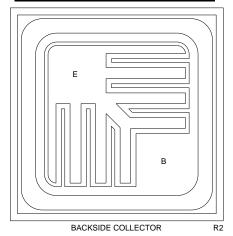


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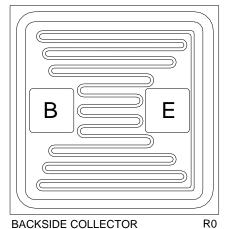
Figures:

Figure 1: CP195 Chip Geometry



Die Size: 30 x 30 mils
Die Thickness: 7.5 mils
Bond Pad Area (Emitter): 8 x 8 mils
Bond Pad Area (Base): 7.2 x 7.2 mils
Topside Metal: Al (30,000Å)
Backside Metal: Au (11,000Å)

Figure 2:CP318V Chip Geometry



Die Size: 26 x 26 mils
Die Thickness: 7.1 mils
Bond Pad Area (Emitter): 5.5 x 5.5 mils
Bond Pad Area (Base): 5.5 x 5.5 mils
Topside Metal: Al-Si (17,000Å)
Backside Metal: Au (12,000Å)

Part Numbers Affected:

CP195-2N3501-CT CP195-2N3501-WN CP195-2N5682-CT CP195-2N5682-WN 2N3501 2N5682

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